High Quality Beams

at Waseda Univ. and Sumitomo Heavy Industries, Ltd.

Yosuke Katsumura

Extremely Low Emittance Electron Beam Its Application for the Inverse Compton Scattering

Yasushi Aoki, Fumio Sakai Sumitomo Heavy Industries, Ltd. FESTA

📀 Sumitomo Heavy Industries, Ltd.

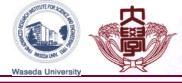


<u>RISE Waseda University</u>

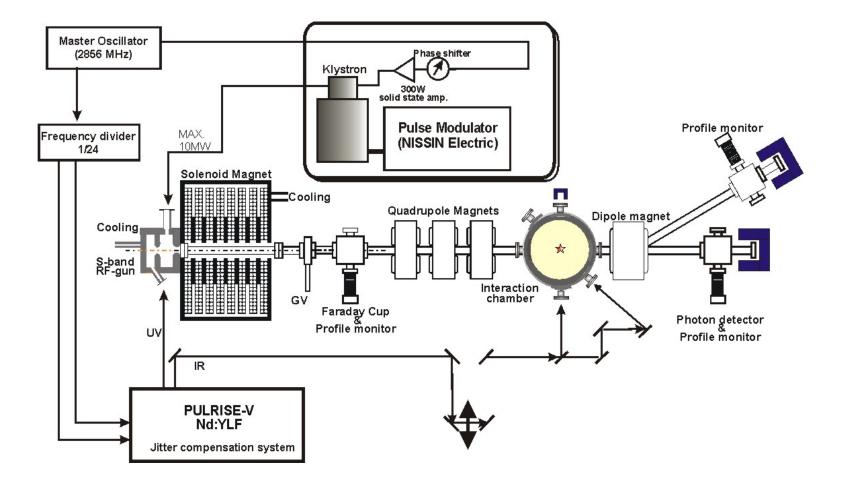
Present status of High Quality Beam Facility at Waseda University

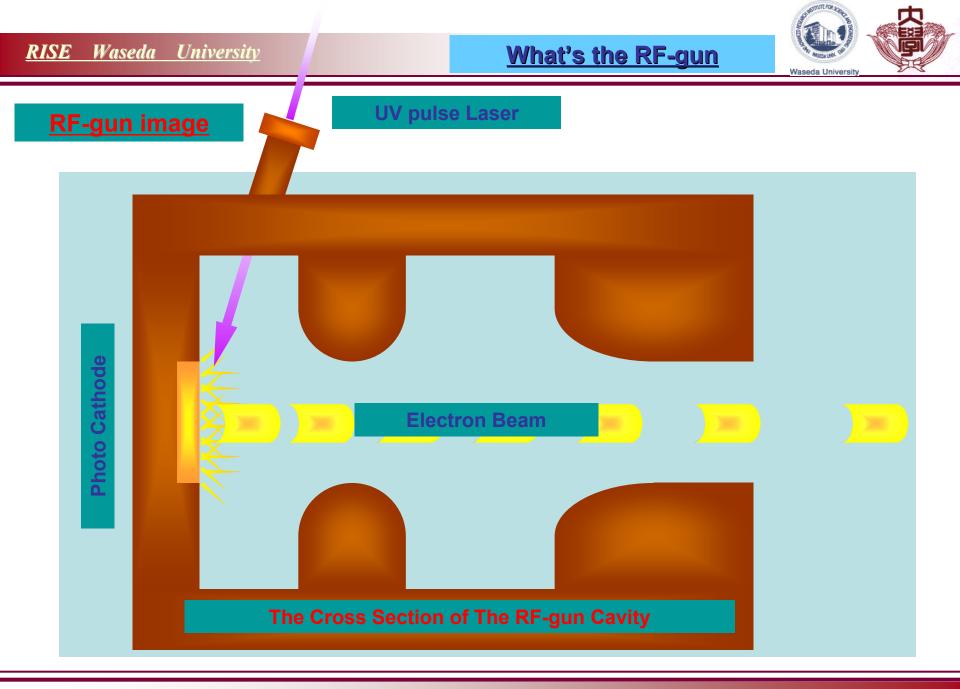
Masakazu WASHIO

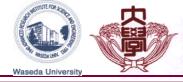
Advanced Research Institute for Science & Engineering Waseda University



Beam Line at Waseda Univ.







RF Gun Assemble





Laser System (Nd:YLF)

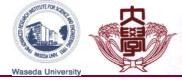
[Pulrise V]

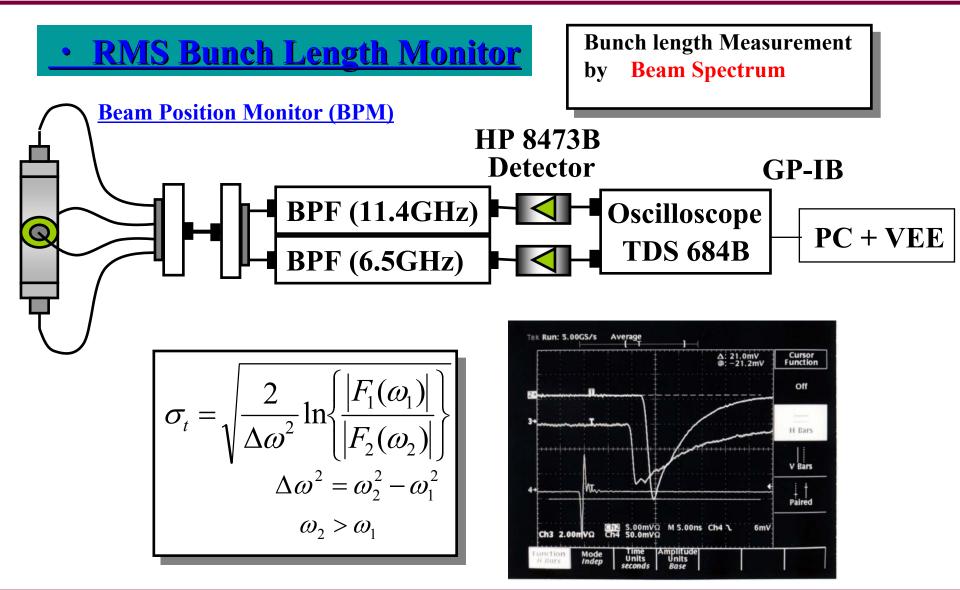
Laser system	: Nd:YLF
Pulse Width (FWHM)	: 10 ps
Energy per Pulse	
UV (262 nm) for RF-gun	: 0.15 mJ
Green(524nm) Probe light	: 0.4 mJ
IR(1047 nm) Collision and Probe	: 1 mJ
Repetition	: 1-25 Hz



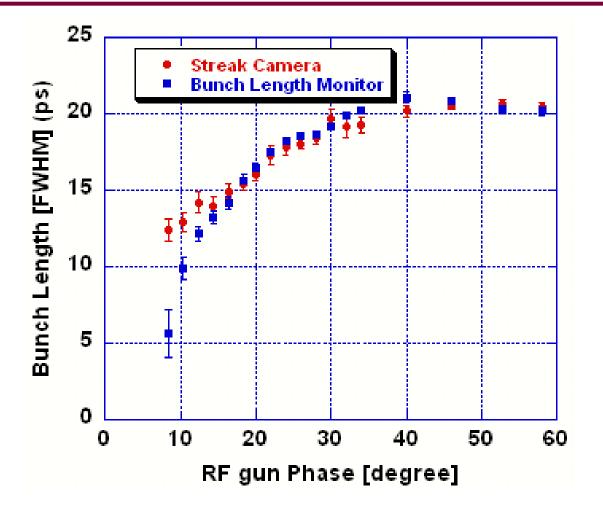
•Timing stabilizer (119MHz seed light)

 Intensity stabilizer (25 Hz UV light)

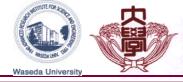


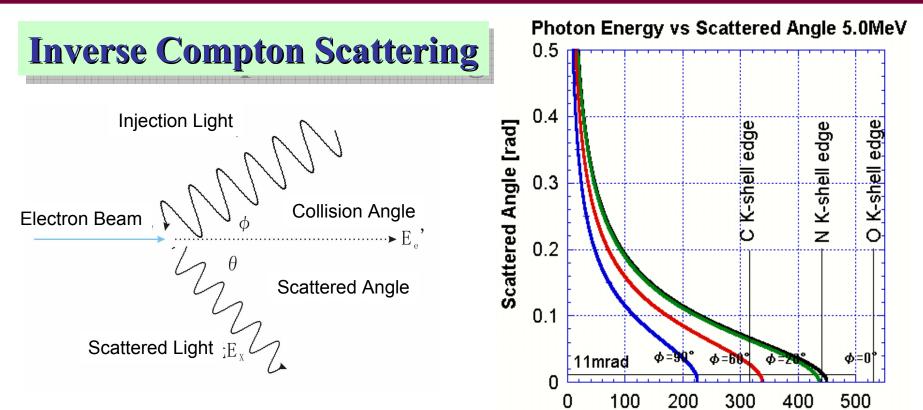






Relationship between Bunch Length and RF Phase for RF-gun





Energy of the X-Ray

$$E_X = \frac{(1+\beta\cos\phi)E_eE_l}{\{1+\cos(\phi+\theta)\}E_e + (1-\beta\cos\theta)E_l\}}$$

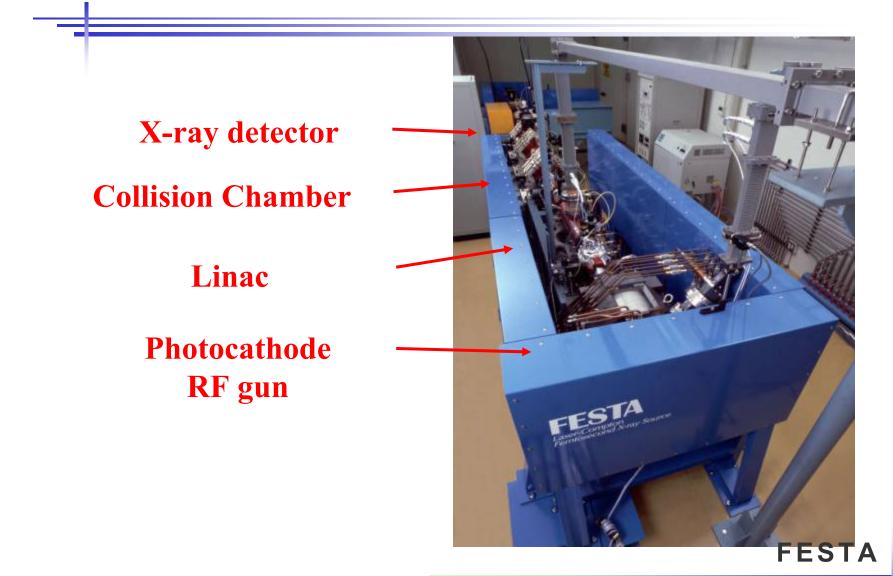
Energy Tunable

- EB Energy
- Wavelength of Laser Light

Photon Energy [ev]

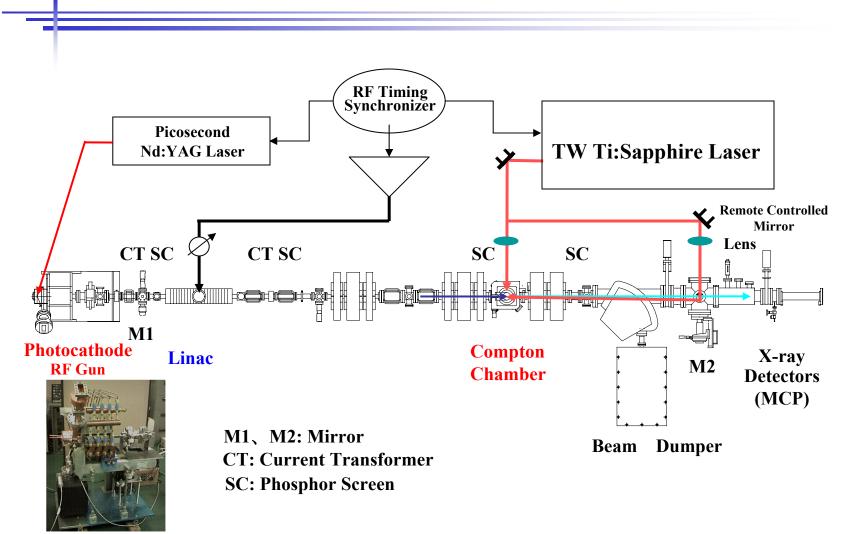
Collision Angle

Electron linac system (1st generation)



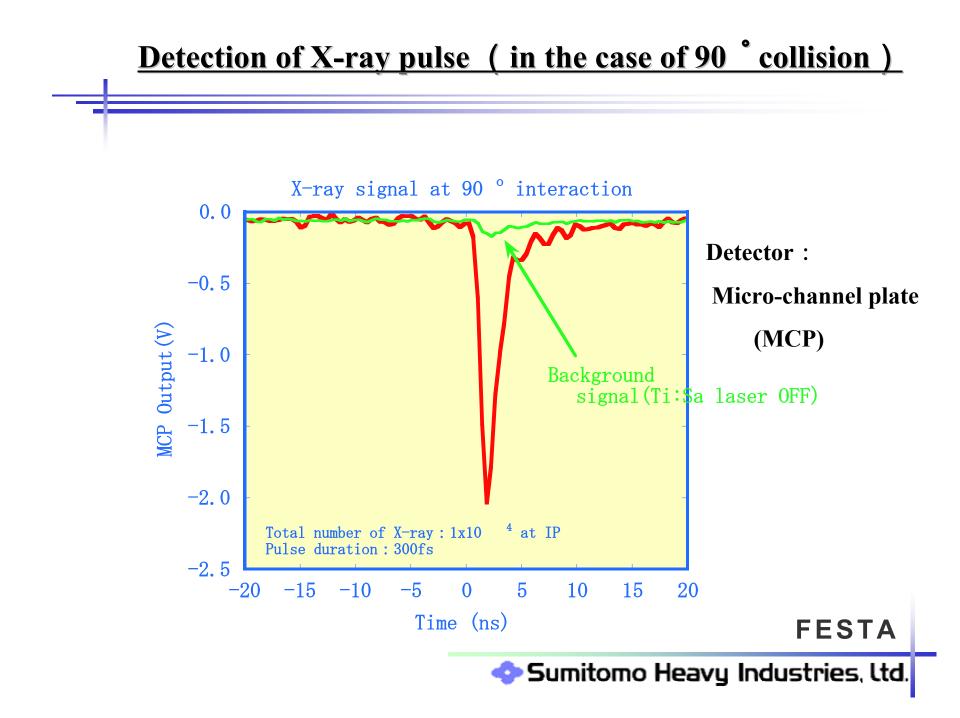
💠 Sumitomo Heavy Industries, Ltd.

Femtosecond X-ray pulse generation system



FESTA

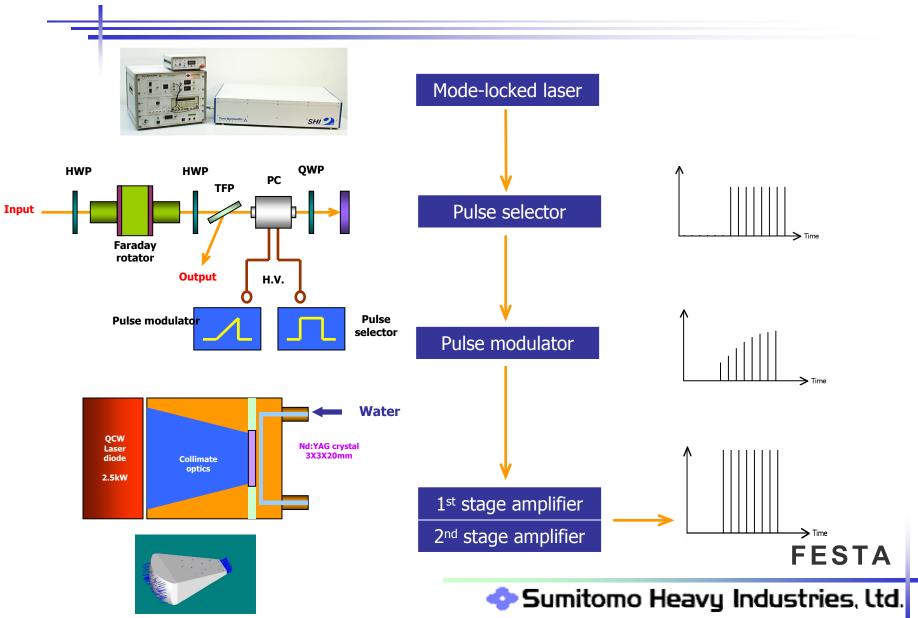
📀 Sumitomo Heavy Industries, Ltd.



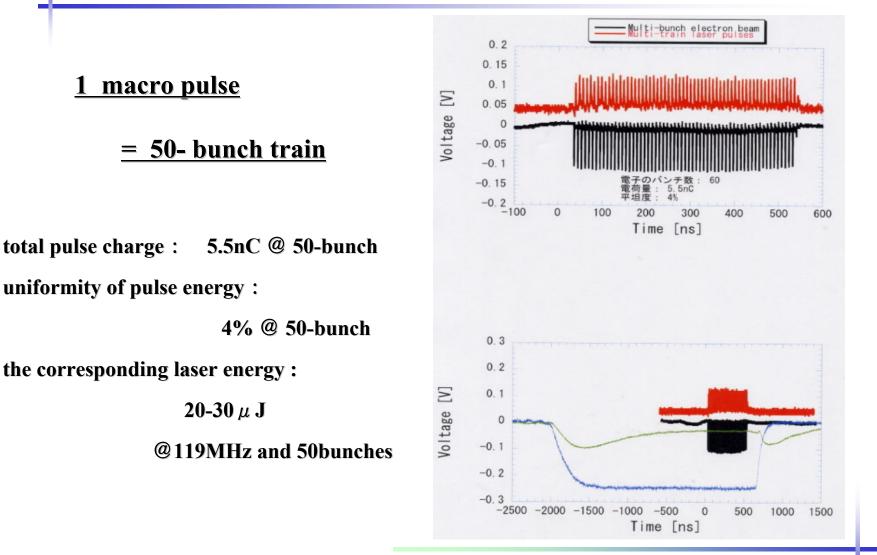
X-ray yields before and after the system improvement X-ray intensity vs laser energy • Increase in (collision angle 180deg.) X-ray photon intensity is 50 attributed to reduction in (10^{4}) the sizes of both beams 40 Before Total X-ray photon number after **Electron beam :** 30 $100 \,\mu \,\mathrm{m} \rightarrow$ 30-50 µ m laser : 20 $120 \,\mu \,\mathrm{m} \rightarrow$ $40 \,\mu \,\mathrm{m}$ 10 0 20 40 60 80 100 0 Laser energy (mJ) **FESTA**

🔷 Sumitomo Heavy Industries, Ltd.

<u>Picosecond multi-train laser</u>



<u>Mg-photocathode RF gun</u> <u>multi-bunch electron beam generation</u>



📀 Sumitomo Heavy Industries, Ltd.

<u>Summary</u>

- **1**. Extremely low emittance electron generation system (RF gun and psec laser)
 - QE : $1 \ge 1 = 0^{-4}$ (Cu), $1 \ge 1 = 0^{-3}$ (Mg)
 - Transverse emittance:2.6mm · mrad @1nC (Nd:YAG 4th harmonics)
 - pulse shape control of laser resulted in

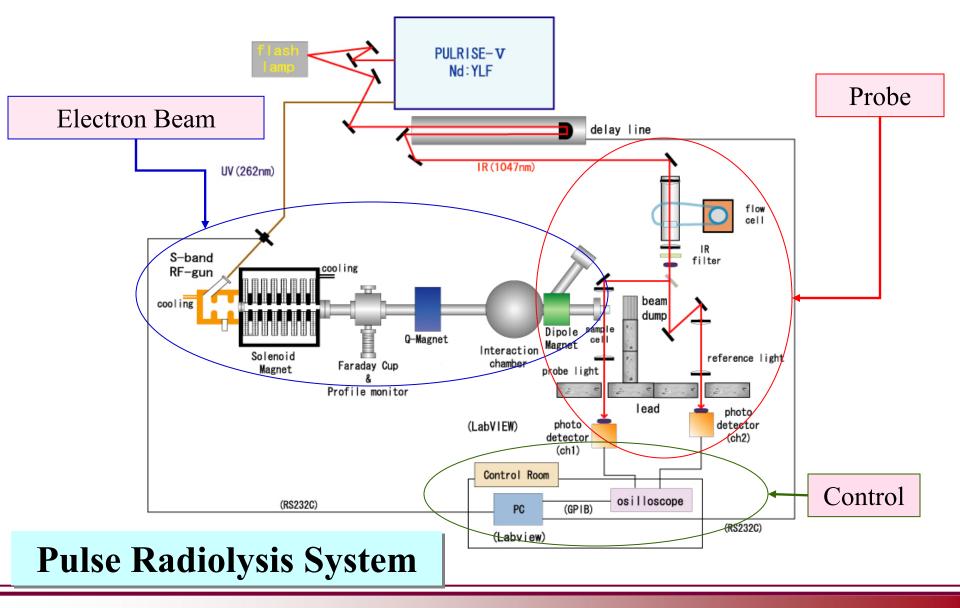
extremely low emittance e beam (1.2mm·mrad@1nC)

- multi-train laser system is under development for intense X-ray beam
- 2. X-ray generation via the inverse Compton scattering
 - \cdot femtosecond X-ray pulse generation at the incident angle of 90degree X-ray intensity: $\sim 1\,$ O 4 photons/pulse
 - 30keV X-ray generation is planning after system improvement electron energy : 40MeV, laser : 0.5J/pulse
 - In the preliminary experiment, around 10-fold increase in intensity was observed.

🔷 Sumitomo Heavy Industries, ltd.

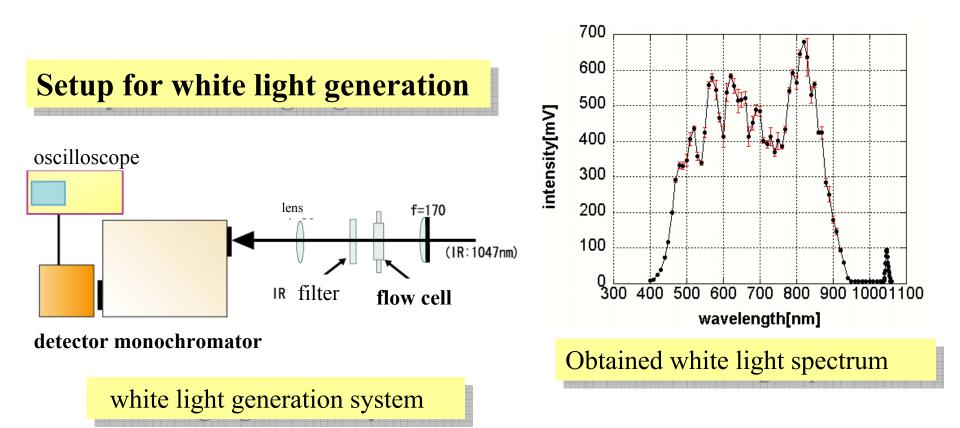
<u>RISE Waseda University</u>





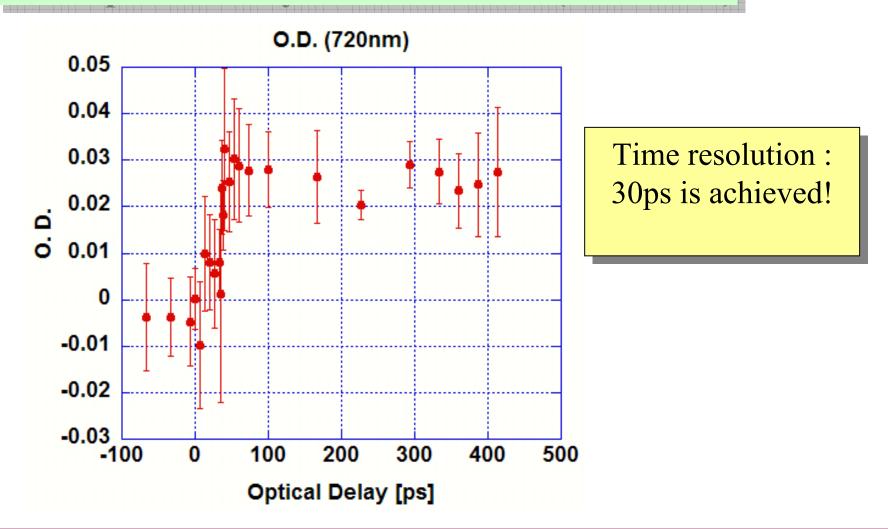








Time profile of hydrated electron (at 720nm)





Summary

- 1. Development of RF Gun System
 - * **RF gun is operating well!**
- 2. Beam Diagnosis
 - (Emittance and Bunch Length Measurements)
 - * Slit scan techniques
 - * RF kicker cavity (in progress)
- 3. X ray Generation (Inverse Compton Scattering)
 - * Soft X-ray with 7.7 ps (rms) was generated!
 - * 5 x 10³ Photons/ pulse
- 4. Pulse Radiolysis System

* ps Pulse Radiolysis System by Stroboscopic Technique